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1

Supplementary Information for

Highly Robust Nanostructured Carbon Films by Thermal 2 **Reconfiguration of Ionomer Binding** 3 4 Jae-Bum Pyota, Ji Hun Kimta, and Taek-Soo Kima 5 ^a Department of Mechanical Engineering, KAIST, 291 Daehak-ro, Yuseong-gu, 6 Daejeon 34141, Korea; 7 8 ‡These authors contributed equally to this work. 9 10 *Corresponding author. E-Mail: tskim1@kaist.ac.kr



- Fig. S1 Swelling-induced electrode separation. (A) Wrinkled and partially delaminated
 electrodes due to swelling mismatch. (B) The self-delaminated area became broader as
 the moisture absorption time increased.



Fig. S2 Pseudo free-standing tensile testing system.



- Fig. S3 Thermally reconfigured electrodes above 230 °C and tensile testing results. (A) Unstably deformed electrodes reconfigured at 270 °C and (B) 310 °C. (C) Deformed electrode attached on the gripping jig. (D) Stress-strain curves for the 270 °C electrode and the 310 °C electrode.



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Fig. S4 XRD spectra as a function of the reconfiguration temperature. (A) XRD spectrum of each electrode treated at different temperatures. (B) Clarified the change of the crystalline morphology of the Nafion binder as the reconfiguration temperature increased.



3 Fig. S5 HAADF-STEM images of the electrode with increasing reconfiguration 4 temperature. (A) Nanostructure of the as-prepared electrode (110 °C). (B) Shortened distance between neighboring agglomerates reconfigured at 150 °C. (C) The 5 6 reconfiguration at 230 °C promoted smooth interconnection and filled the small voids. (D) 7 Neighboring agglomerates in the as-prepared electrode (110 °C) were initially 8 disconnected. (E and F) The distance of disconnected applomerates were shortened at 9 150 °C, but they still not sufficiently connected by Nafion binder (E). The inset shows 10 elemental mapping of carbon (green) and cesium stained Nafion (red). Increasing the 11 reconfiguration temperature to 230 °C allowed ionomer's melt flow in nanoscale (F).



6 Fig. S7 Scanning electron microscopy images of 110 and 230 °C electrodes with







Fig. S8 Optical microscope images of 110 and 230 °C electrode EAPs experiencing cyclic bending loads. (A–C) Initially, the 110 °C electrode EAP was assembled without any defects (A). The cyclic loads at 2 % bending strain caused the electrode's crack (B), and this crack propagated as the strain increased to 3 % (C). (D–F) Initially, the 230 °C electrode EAP was also assembled without any defects (D). This EAP demonstrated sufficient robustness to cyclic loads at 2 % (E) and 3 % (F) of bending strain, which is attributed to the higher mechanical strength.



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Fig. S9 Actuation performance affected by cyclic bending loads. (A) The 110 °C electrode EAP showed degradation of the actuating displacement as the cyclic bending strain increased. (B) The 230 °C electrode EAP maintained the initial actuating displacement, even after 3 % cyclic loads, which is attributed to sufficiently enhanced mechanical robustness.